

Image

In re Application of:



KIYOFUMI SAKAGUCHI, ET AL.

Appln. No.: 10/085,046

Filed: March 1, 2002

For: PROCESS FOR PRODUCTION OF  
SEMICONDUCTOR SUBSTRATE

Docket No. 03500.010530.5

Examiner: G. Fourson, III

Group Art Unit: 2823

Date: February 17, 2004  
(Tuesday after Monday holiday)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Response to Restriction Requirement and Election of Species Requirement and Submission of Sworn Translations of Priority Documents in the above-identified application.

☒ No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	96	MINUS	96	0	x \$ 9 \$18	\$ 0.00
INDEP. CLAIMS	33	MINUS	33	0	x \$43 \$86	\$ 0.00
Fee for Multiple Dependent claims \$145/\$290						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$ 0.00

☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.

☐ A check in the amount of \$\_\_\_\_\_ is enclosed.

☐ Charge \$\_\_\_\_ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.

☒ Any prior general authorization to charge an issue fee under 37 C.F.R. § 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. §§ 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.

☐ A check in the amount of \$\_\_\_\_\_ to cover the Extension fee for response within \_\_\_\_\_ months is enclosed.

☐ A check in the amount of \$\_\_\_\_\_ to cover the Information Disclosure Statement fee is enclosed.

☒ Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

Daniel S. Glueck

Registration No. 37,838

FITZPATRICK, CELLA, HARPER & SCINTO  
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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: G. Fourson, III
KIYOFUMI SAKAGUCHI, ET AL.	)	
	:	Group Art Unit: 2823
Application No.: 10/085,046	)	
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Filed: March 1, 2002	)	
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For: PROCESS FOR PRODUCTION	)	
OF SEMICONDUCTOR	:	
SUBSTRATE	)	February 17, 2004
		(Tuesday after Monday holiday)

Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT  
AND ELECTION OF SPECIES REQUIREMENT AND  
SUBMISSION OF SWORN TRANSLATIONS OF PRIORITY DOCUMENTS

Sir:

INTRODUCTORY COMMENTS

In response to the Official Action dated January 16, 2004, the Examiner is respectfully requested to enter and consider the following remarks: